



IFW
2811

Attorney Docket SEL 203

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
NAKAJIMA et al.)
)
Serial No.: 09/635,945)
)
Filed: August 10, 2000)
)
For: Semiconductor Device And Method)
Of Manufacturing The)
Semiconductor Device)
)
Art Unit: 2811)
)
Examiner: S. Hu)

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Shannon Wallace

Name of applicant, assignee, or Registered Rep.

Shannon Wallace 8/19/04

Signature

Date

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT F

In response to the Office Action of April 19, 2004, a one month extension of time being submitted herewith, please amend the above-identified application as follows: